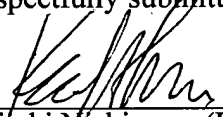


In paragraph 3 of said office action, the Examiner directed applicant's attention to Fig. 5(a) and column 1, lines 49+ of reference by Matsui. In Amendment "A" submitted by applicant in response thereto, applicant stated that Matsui does not disclose every inventive element in independent claim 1, and hence that the Examiner's rejection of claim 1 and the claims dependent therefrom is not justified. Applicant went further in detail and said that claim 1 contains many constituent inventive elements, one of which is the step of forming an anisotropic conductive layer on a target surface such that the plurality of terminal forming areas which have been specified on this target surface will be spanned. In Paragraph 3 of the Official Letter, however, the Examiner stated that Matsui provides "all teachings of claim 1 comprising; a conductive layer on the target surface, placing a plurality of electrical components Fig. (5a) on the semiconductive layer; and pressing the assembly together". In other words, the Examiner totally ignored the inventive element in claim 1 related to the anisotropic conductive layer (shown at 5) spanning a plurality of terminal-forming areas (3a and 3b). This argument was already presented in said Amendment "A" but the Examiner has not commented on it in said Final Office Action. Applicant therefore believes that the Examiner thereby failed to comply with the requirement specified in 37 C.F.P. 1.104(b) requiring the Examiner's action to be complete.

In other words, applicant is of the opinion that the cited reference does not predicate the Examiner's rejection and further that since the Examiner failed to comply with the requirement for completeness of the Examiner's action, the finality of the rejection should at least be removed.

Respectfully submitted,



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